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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Aaron Frank, et al.	Docket No.: TI-33974
Serial No.: 10/645,975	Art Unit: 1742
Filed: August 22, 2003	Examiner: William T. Leader
Customer No. 23494	Conf. No.: 8382
For: System for In Situ Seed Layer Remediation	

CERTIFICATION OF FACSIMILE TRANSMISSION

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<input type="checkbox"/> CONTINUATION APP'N (# Pages)	<input checked="" type="checkbox"/> Election
<input type="checkbox"/> DIVISIONAL APP'N	
NAME OF INVENTOR(S): Aaron Frank, et al.	RECEIPT DATE & SERIAL NO.: Serial No.: 10/645,975 Filing Date: August 22, 2003
TITLE OF INVENTION: System for In Situ Seed Layer Remediation	
TI FILE NO.: TI-33974	DEPOSIT ACCT. NO.: 20-0668
FAXED: 12/15/2005 DUE: 12/25/2005 ATTY/SECY: JJG/ms	

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	Aaron Frank, et al.	Docket No.:	TI-33974
Serial No:	10/645,975	Filed:	August 22, 2003
Art Unit:	1742	Examiner:	William T. Leader
Customer No.:	23494	Conf. No.:	8382
Title:	System for In Situ Seed Layer Remediation		

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<i>Marianna Smith</i> Marianna Smith	<i>12-15-05</i> Date

Dear Sir:

With respect to the Restriction Requirement mailed on 11/28/2005, the Examiner has restricted the instant application to the invention of Group I (Claims 1-17), or Group II (Claims 18-21). In light of this, Applicants elect to pursue Group I, (Claims 1-17) without traverse.

Respectfully submitted,



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